

1/7

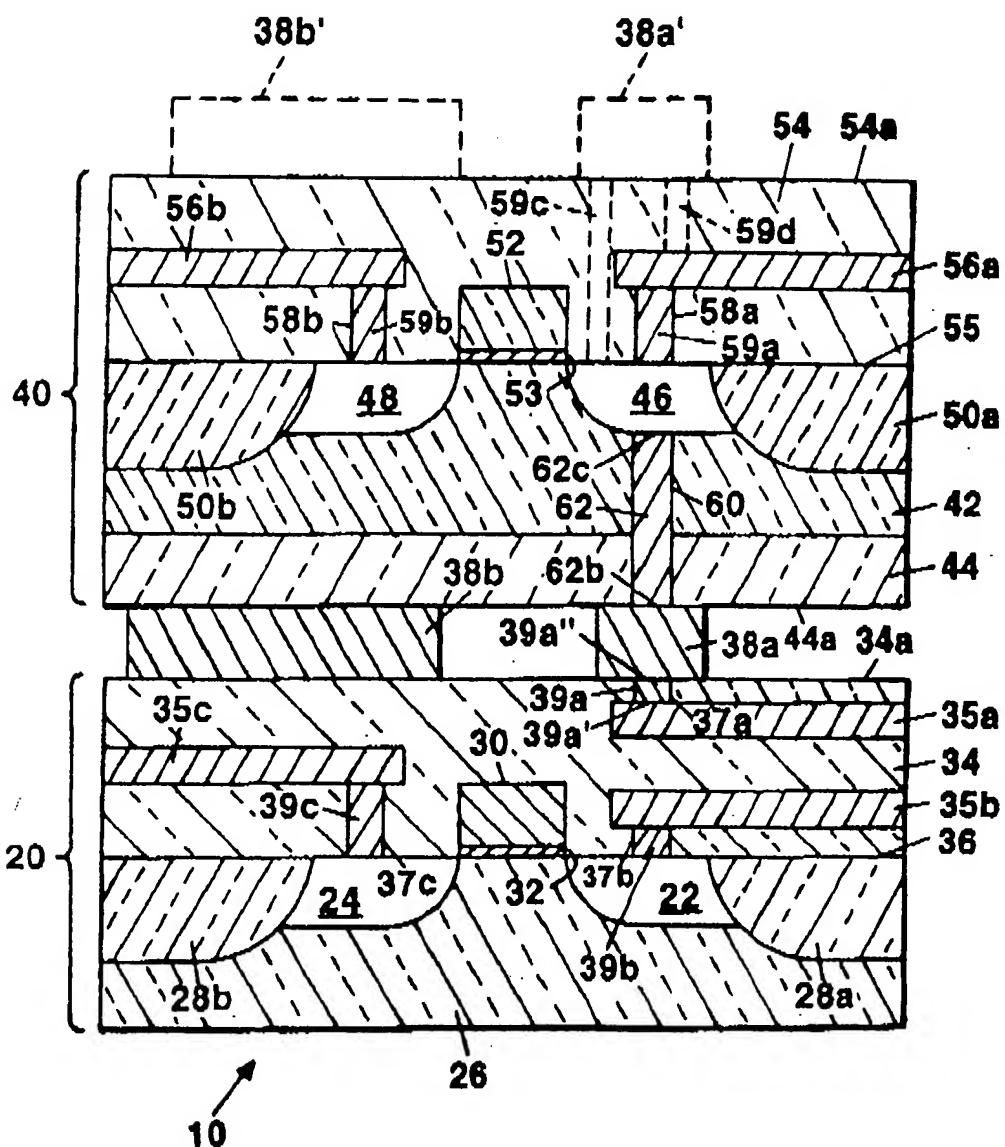


Fig. 1

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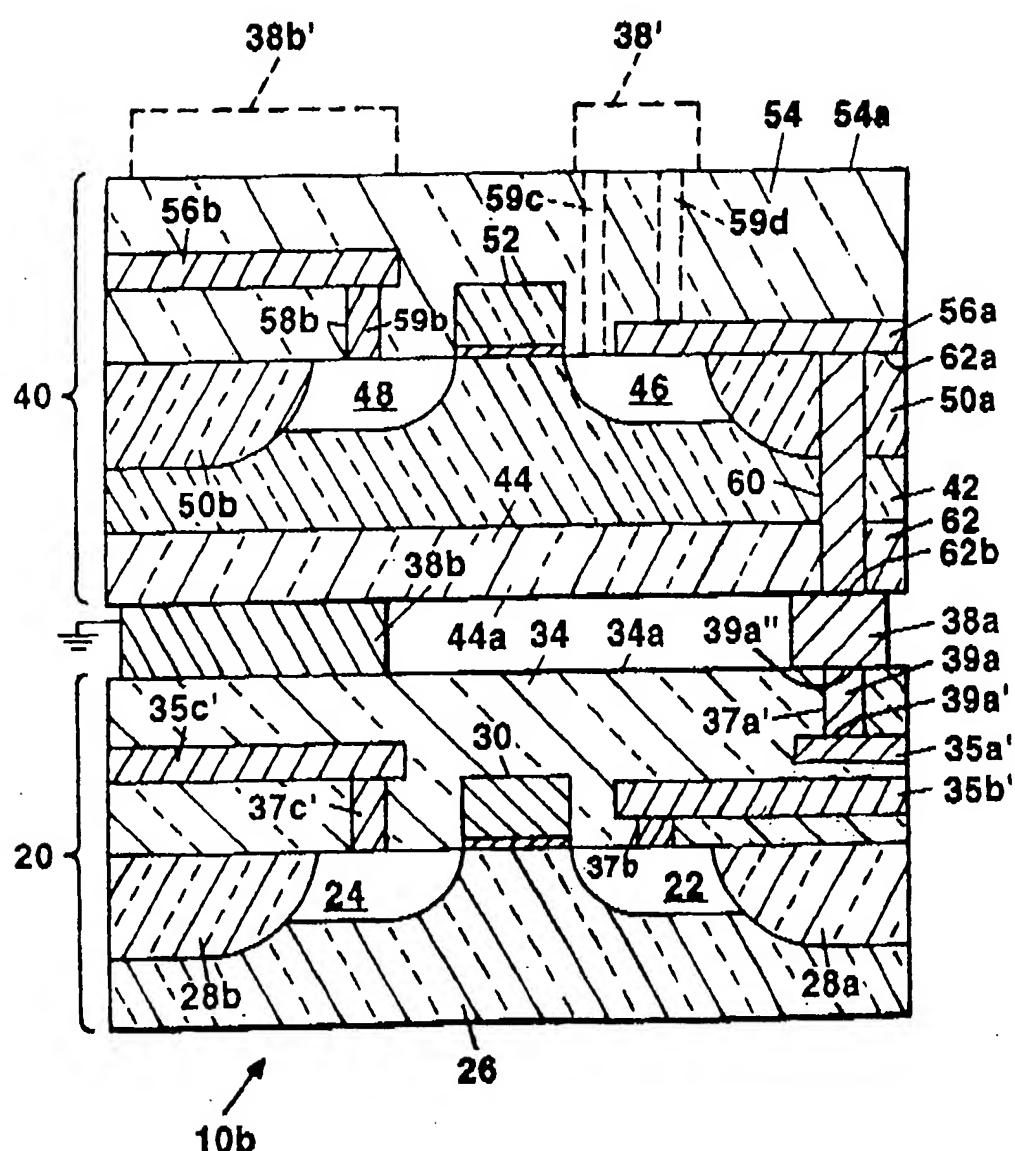


Fig. 2

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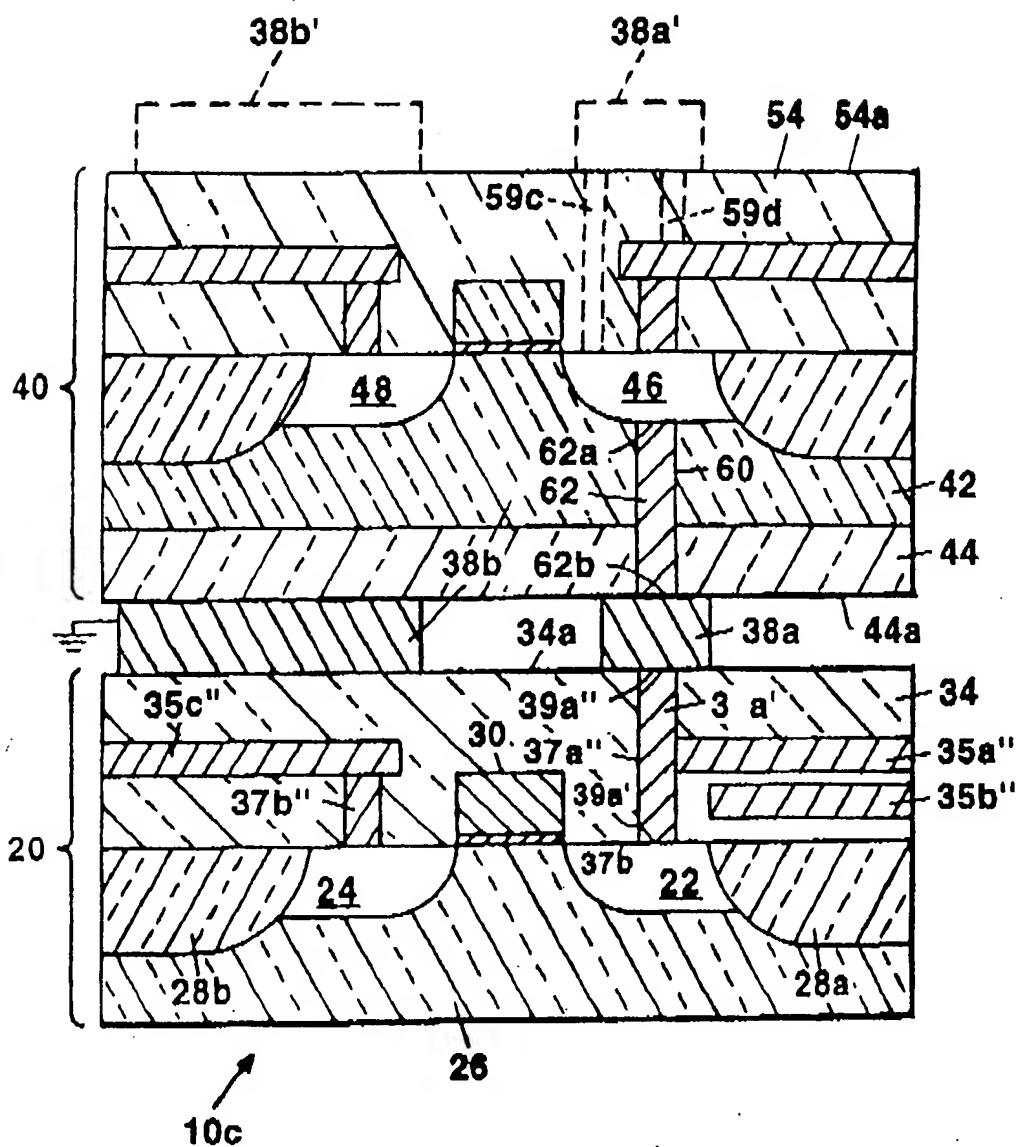


Fig. 3

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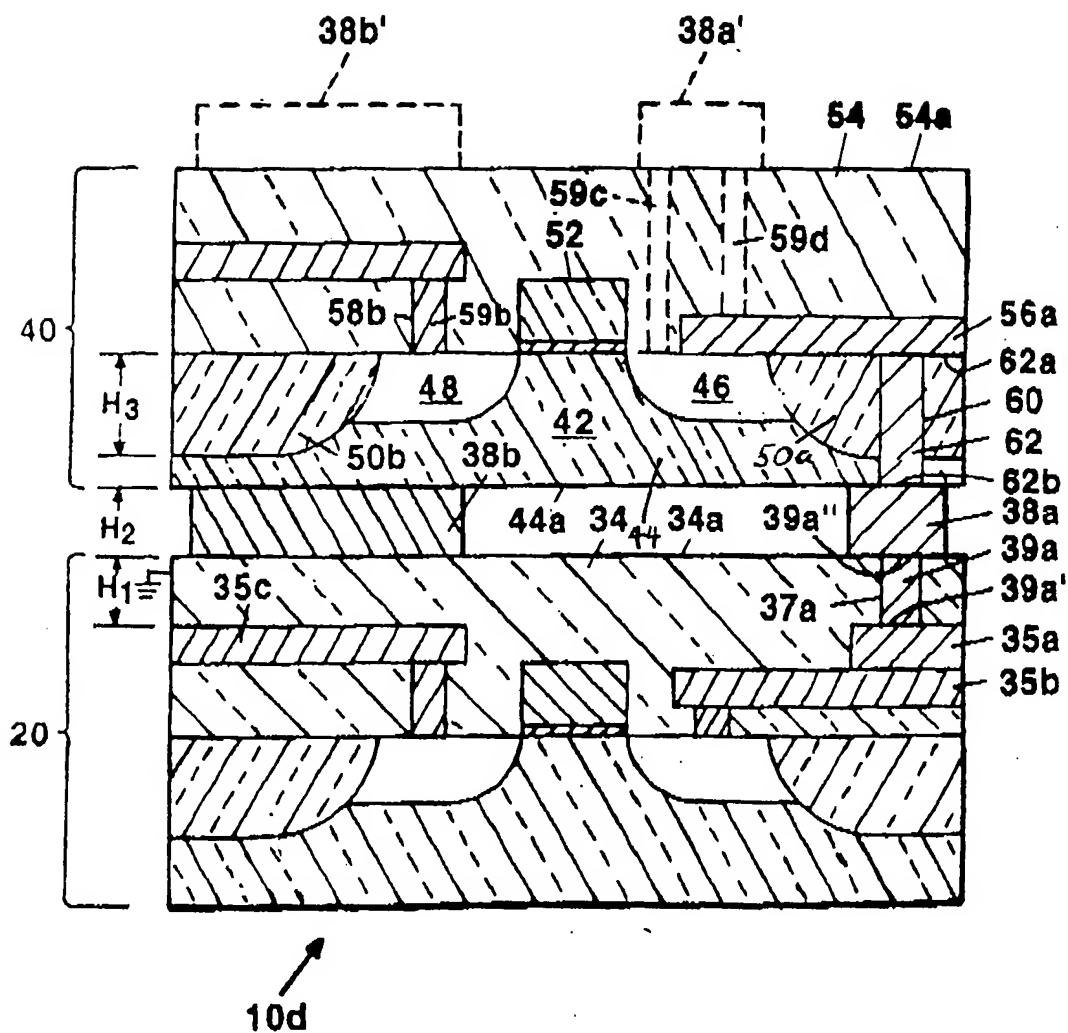


Fig. 4

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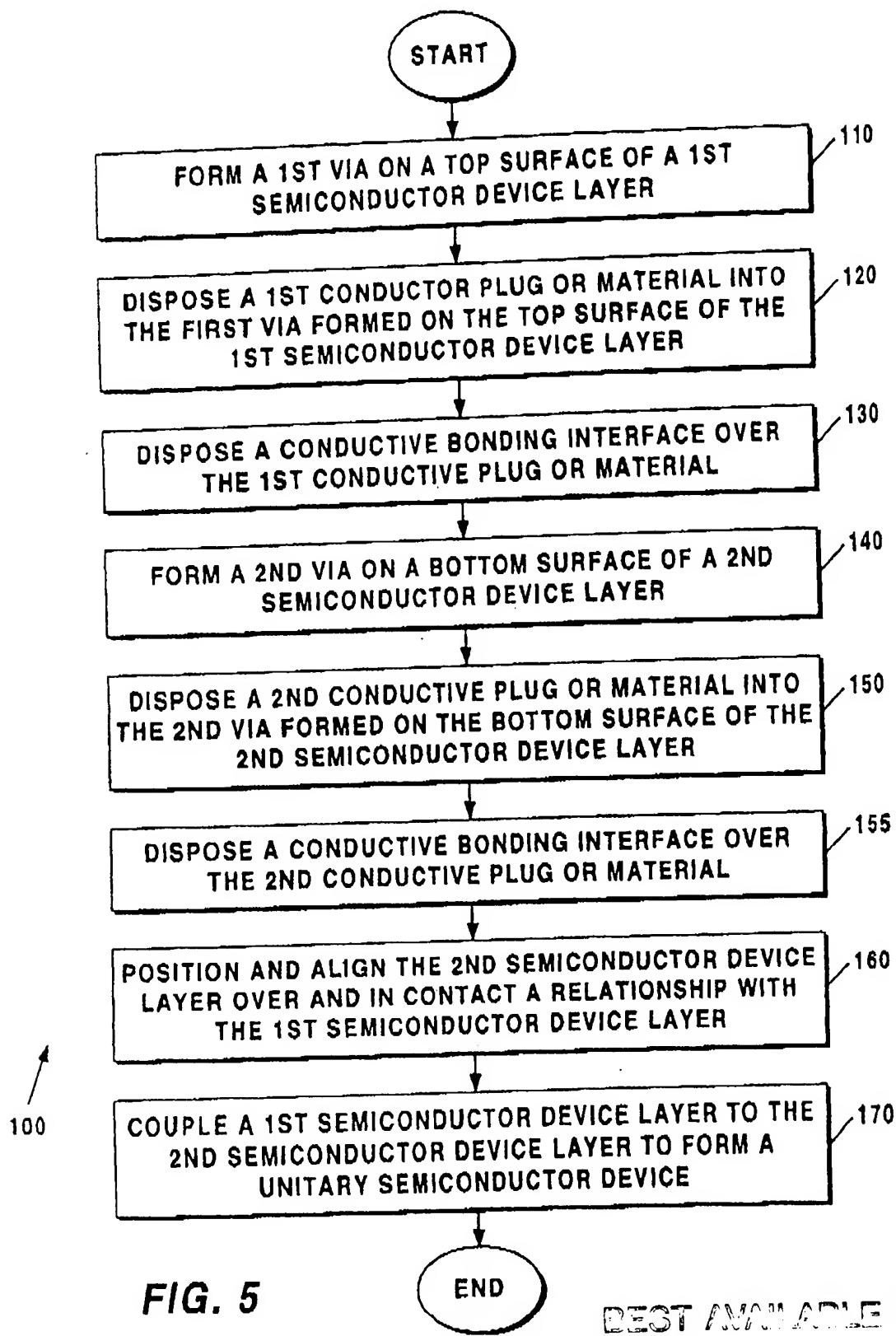


FIG. 5

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MULTI-LAYER INTEGRATED SEMICONDUCTOR STRUCTURE HAVING AN ELECTRICAL SHIELDING PORTION

Rafael Reif, et al.

MIT-136DUS

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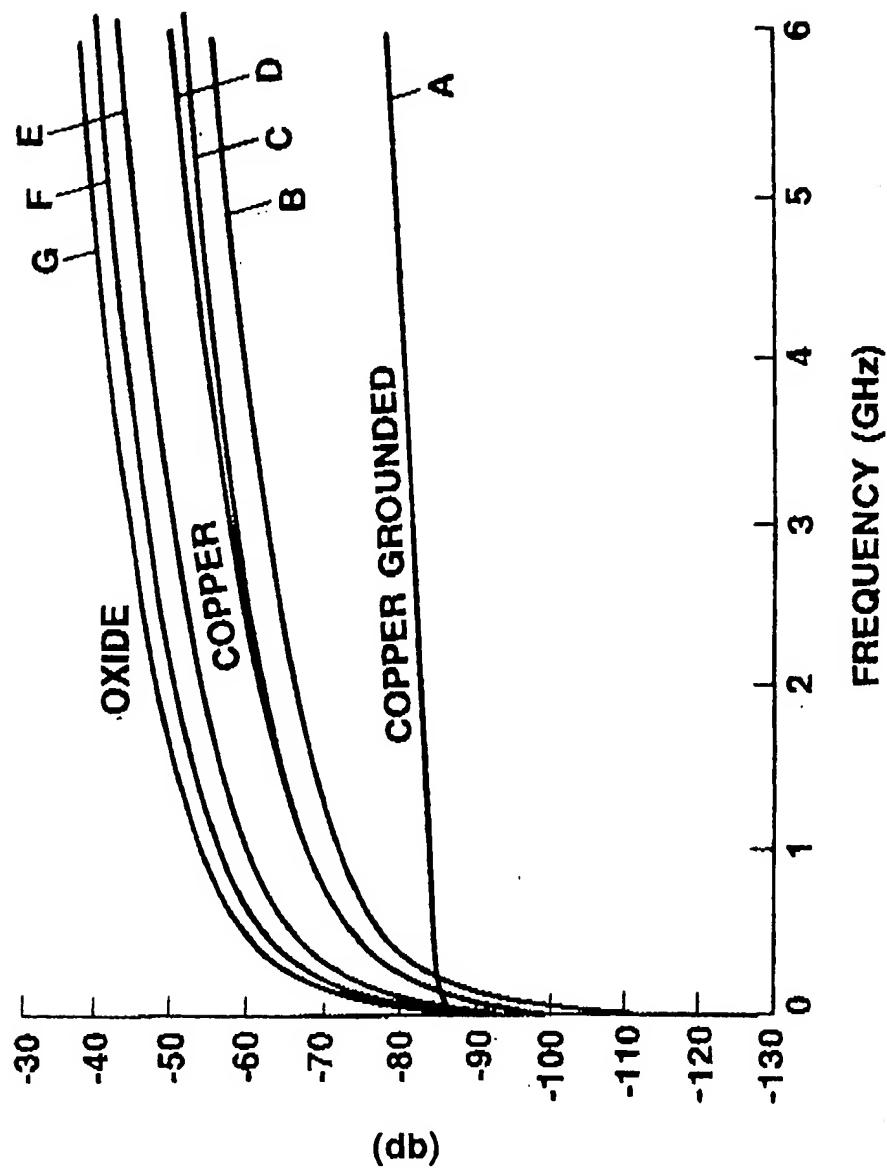


FIG. 6

DO NOT MAKE ANY COPY

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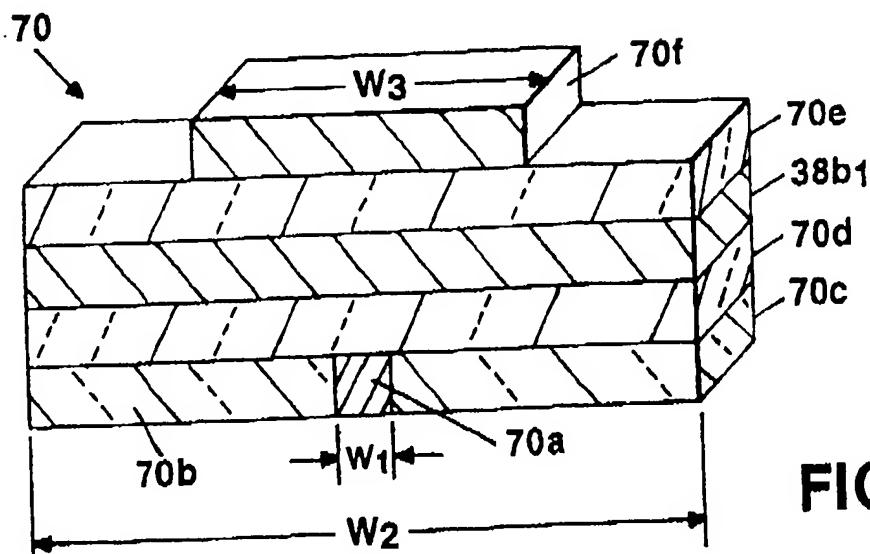


FIG. 7

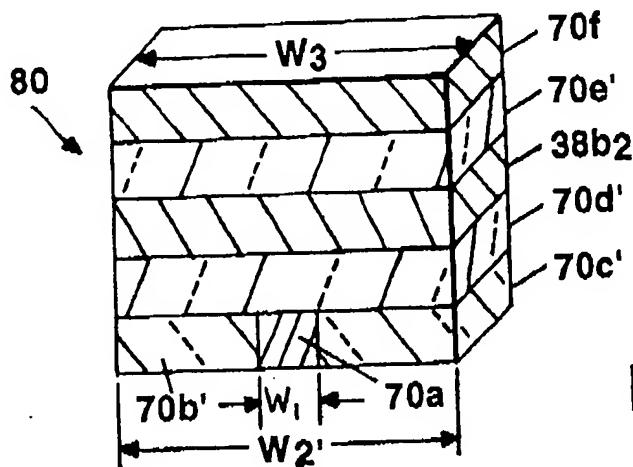


FIG. 8

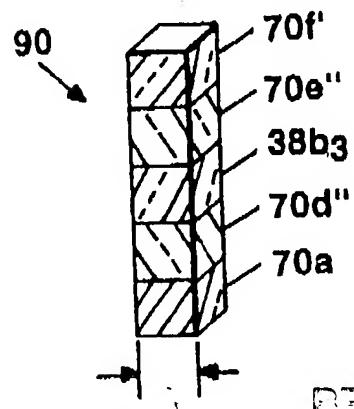


FIG. 9

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